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10/591.718	00/05/0000	Keita Ishiduka	1608-7 PCT/US
APPLICATION NUMBER	FILING OR 371(c) DATE	FIRST NAMED APPLICANT	ATTY, DOCKET NO,/TITLE

CONFIRMATION NO. 3280

23869 HOFFMANN & BARON, LLP 6900 JERICHO TURNPIKE SYOSSET, NY11791

Title: Positive-type resist composition for liquid immersion lithography and method for forming resist pattern

Publication No. US-2007-0190448-A1 Publication Date: 08/16/2007

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